

NANOPHYSIQUE

INTRODUCTION PHYSIQUE AUX NANOSCIENCES

Ch. 4 : Crystal Growth

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Lecture 5, 2022-2023

Crystal Growth

- Crystal growth mechanisms
- Simulations of crystal growth: the SOS model
 - Impurities and step blocking
 - Macrosteps
- Simulations of crystal growth: including fluid transport
 - Density profiles
 - Macrosteps
 - Islands

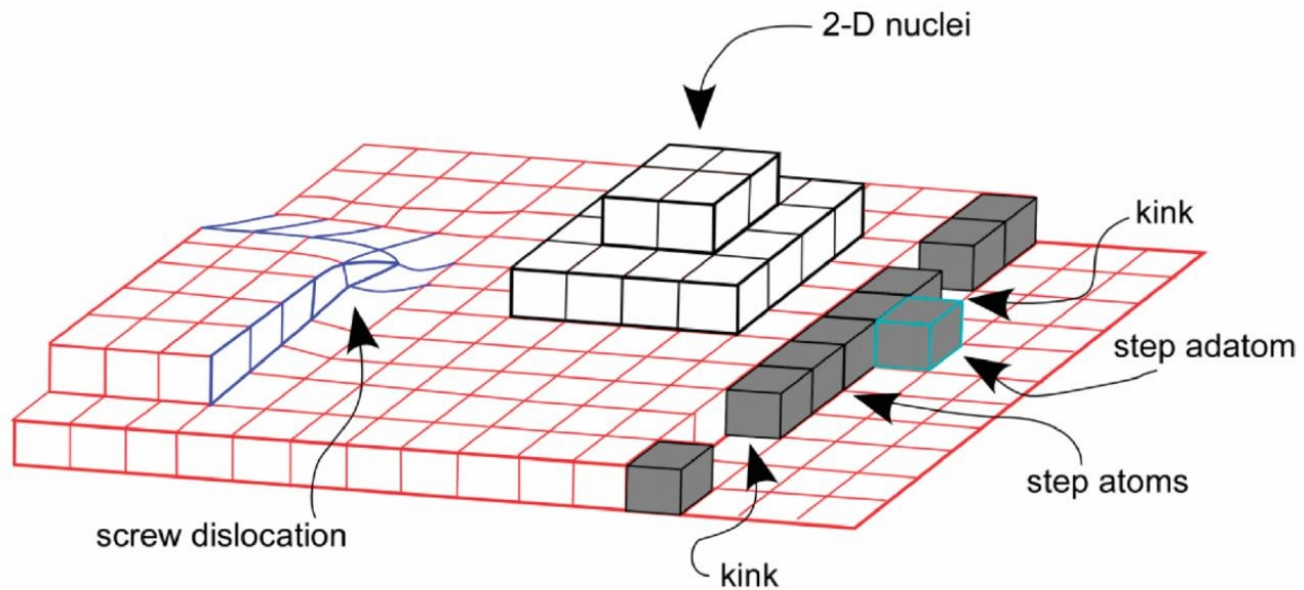
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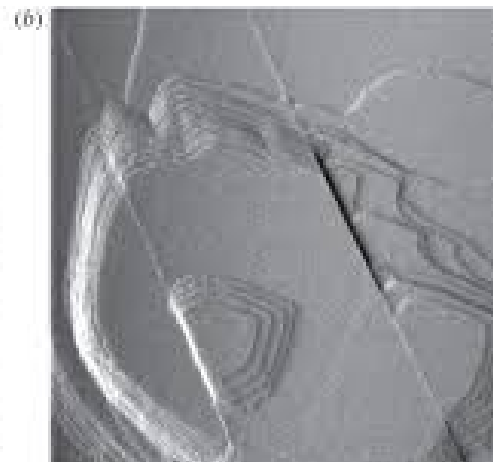
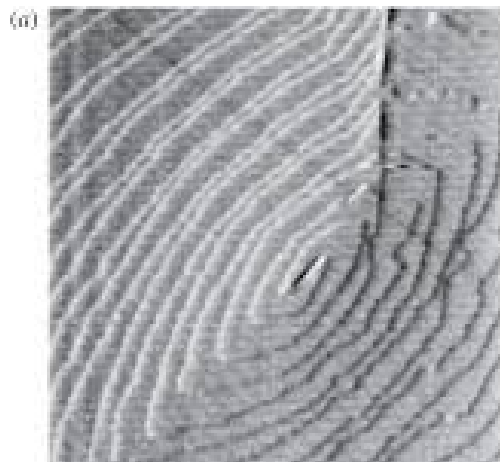
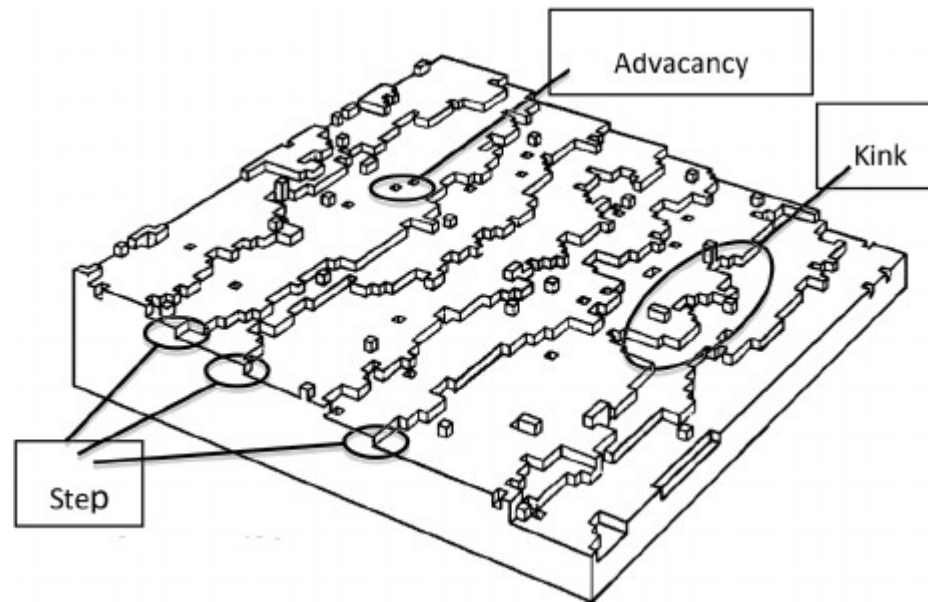
How crystals form



How crystals grow



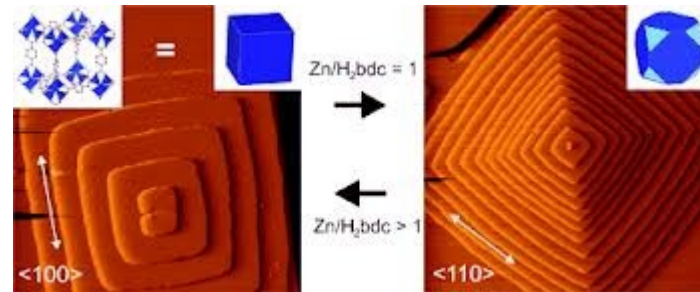
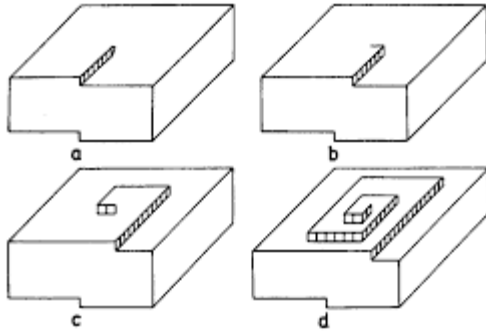
How crystals grow



Motivation: The importance of understanding the effect of impurities on crystallization

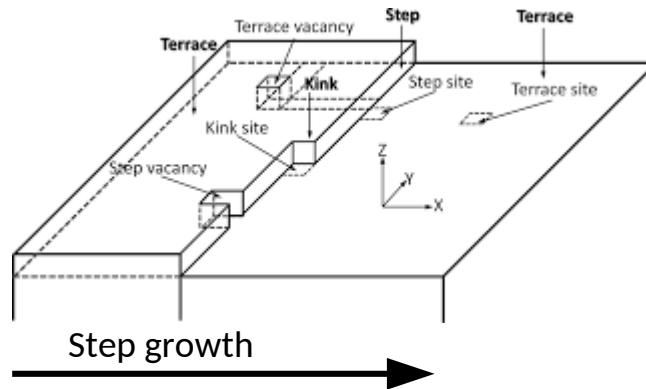
- Many applications require high-quality crystals (e.g. for Xray diffraction) and impurities can spoil crystal quality
- Other applications require the suppression of crystallization and adding the right impurities can be beneficial (*but what are the right impurities?*)
- In some cases, impurities are used to control crystallization (e.g. in biomineralization).

Crystal growth from solution



- Defects – such as spiral dislocations – give rise to steps
- At higher supersaturations, 2D nucleation of islands also occurs

Crystal growth from (pure) solution



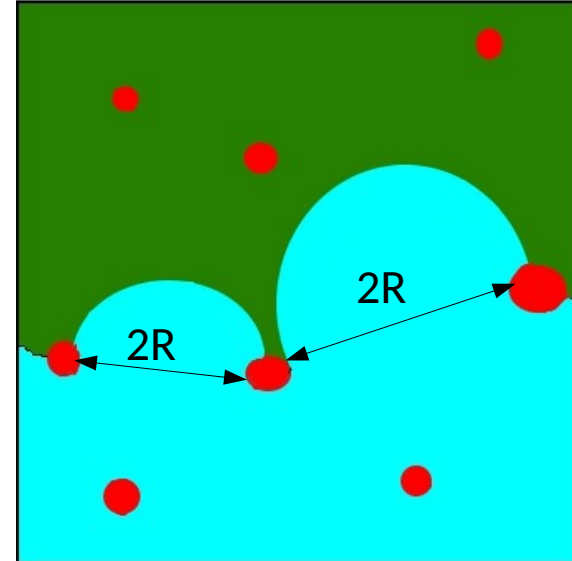
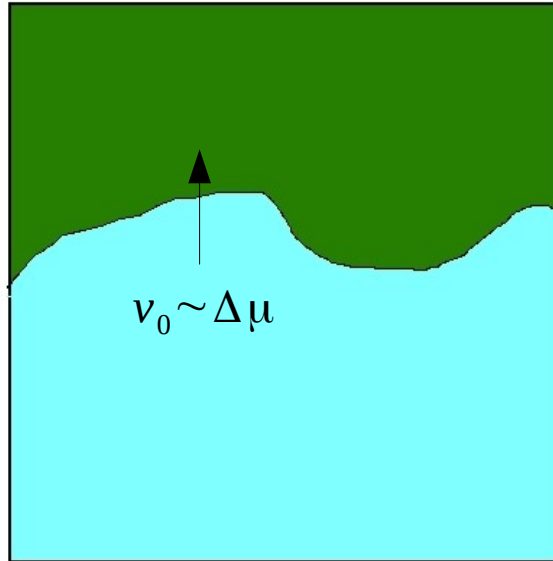
- Bond counting: in cubic solid, each molecule has 6 neighbors
and therefore has total binding energy -3ϵ

- Equilibrium chemical potential (e.g. energy of a molecule in solution) is therefore
$$\mu_{eq} = -3\epsilon$$

- Molecules preferentially attach at kink sites where they can form three bonds:
$$\Delta E = -3\epsilon - \mu = -(\mu - \mu_{eq}) = -\Delta\mu$$

- To start a new line, a stable kink must nucleate.

Crystal growth with impurities: The Cabrera-Vermilyea model



Gibbs-Thompson: effective chemical potential on a curved boundary is

$$\Delta\mu_{eff} = \Delta\mu (1 - R_c/R)$$

where R_c is critical radius for 2D nucleation.

CV criterion for step pinning:

$$R < R_c \Rightarrow \Delta\mu_{eff} < 0 \Rightarrow \text{pinning}$$

CV model for step velocity:

$$v = \sqrt{v_0 \times v_0 (1 - R_c/R)} = v_0 \sqrt{1 - R_c/R}$$

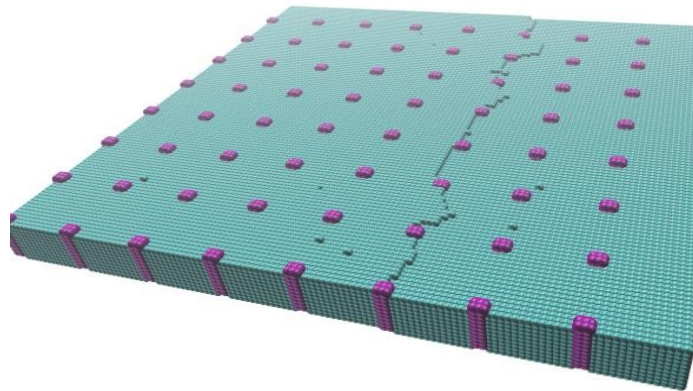
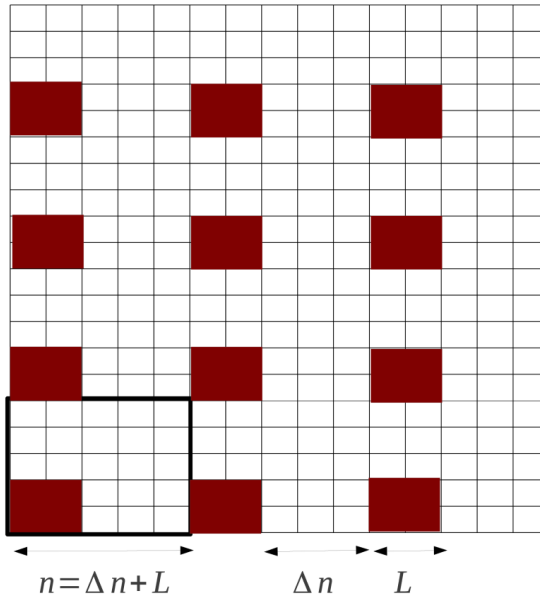
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Kinetic Monte Carlo simulations

Impurities: molecules with different bond energy that differs from the growth units (e.g., zero in horizontal plane).

Impurities can be *static* or *dynamic*



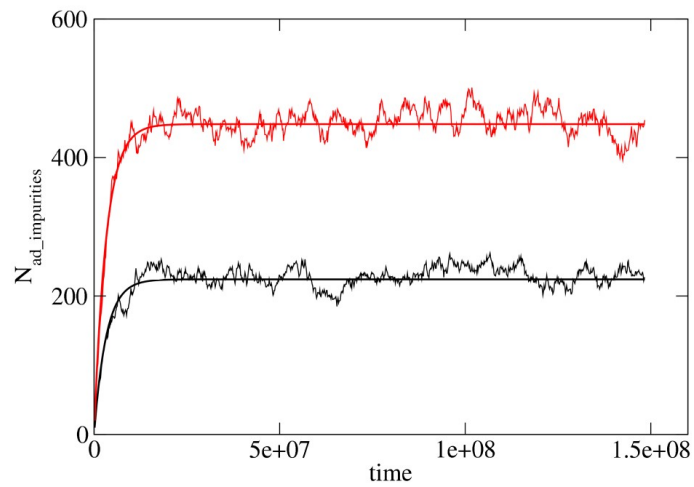
- Molecules land on surface with frequency
- Molecules leave surface with frequency
- Diffusive moves also possible

$$\nu_0 e^{\mu/k_B T}$$

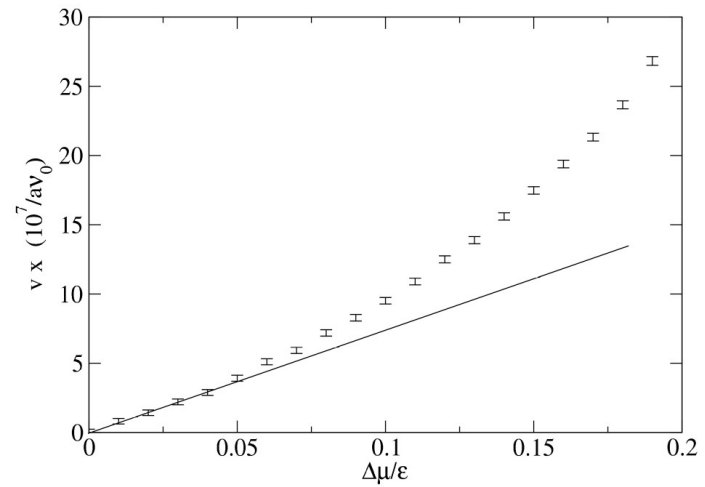
$$\nu_0 e^{E/k_B T}$$

Equilibrium & Normal Growth

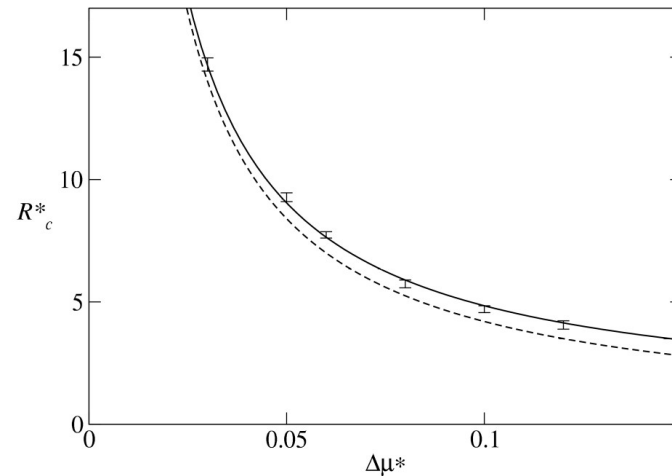
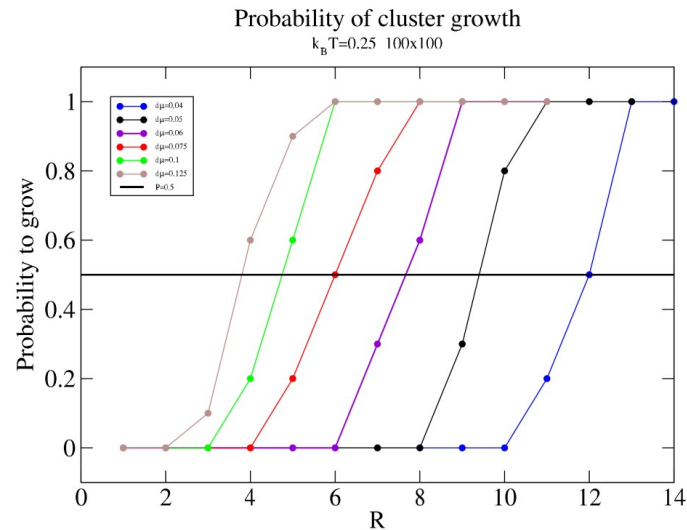
Equilibration



$$k_B T = 0.25 \epsilon$$



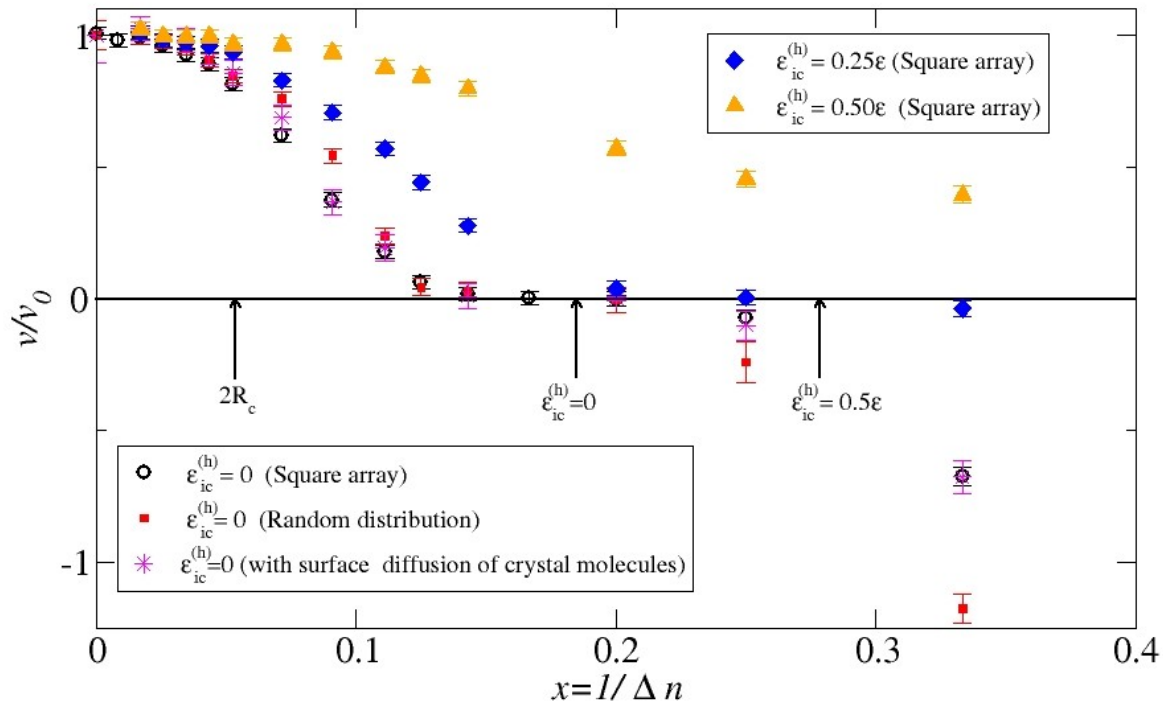
Empirical Critical Radius



Protocol:

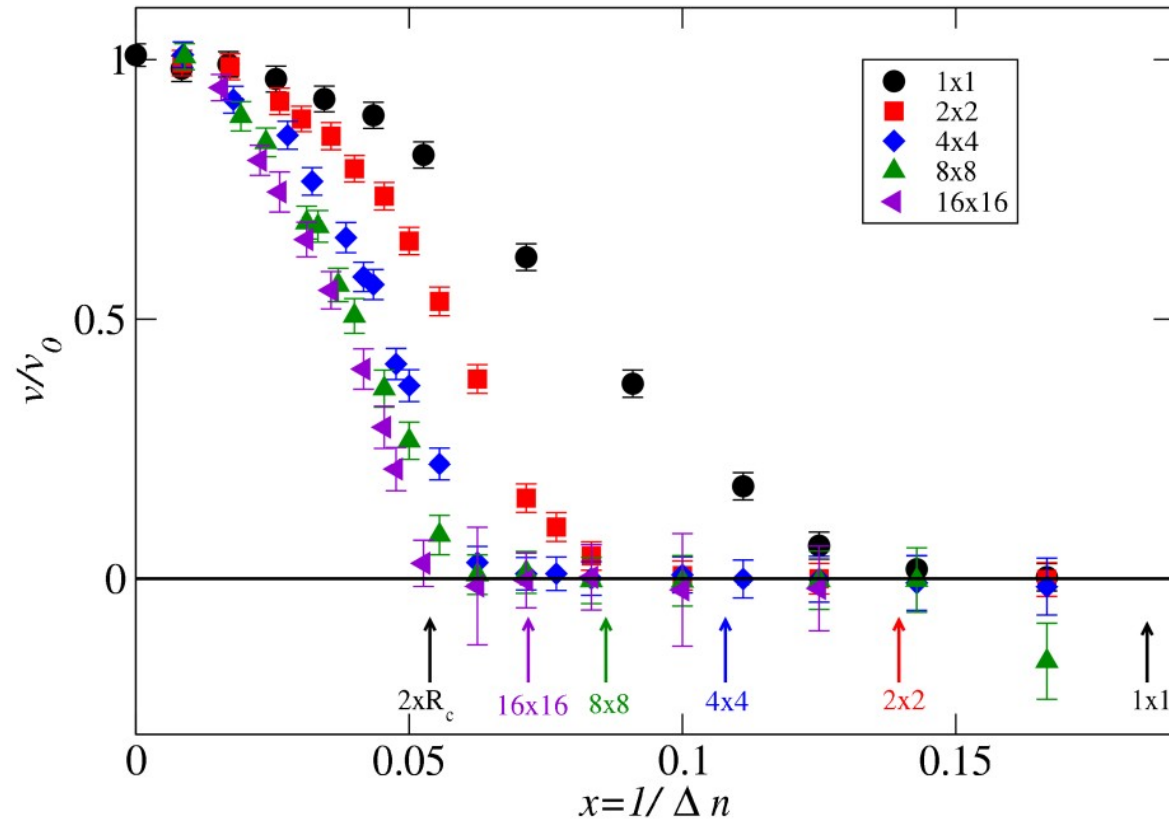
- Start with cluster of given size
- Run until cluster either evaporates or grows above threshold
- Repeat N (~ 100) times to get probability of cluster growth
- $P=0.5$ determines critical radius

Test of CV: small impurities



- Pinning does not occur anywhere near the CV threshold.
- Energetics of the impurities also affects pinning.

Test of CV: larger impurities



- Size of impurities is very important
- Large impurities seem to approach CV prediction.

Beyond CV: the physical basis of step pinning

- It is certainly true that above the CV threshold, steps are not pinned.

$$\Delta n > 2 R_c \quad \longrightarrow \quad \text{No pinning}$$

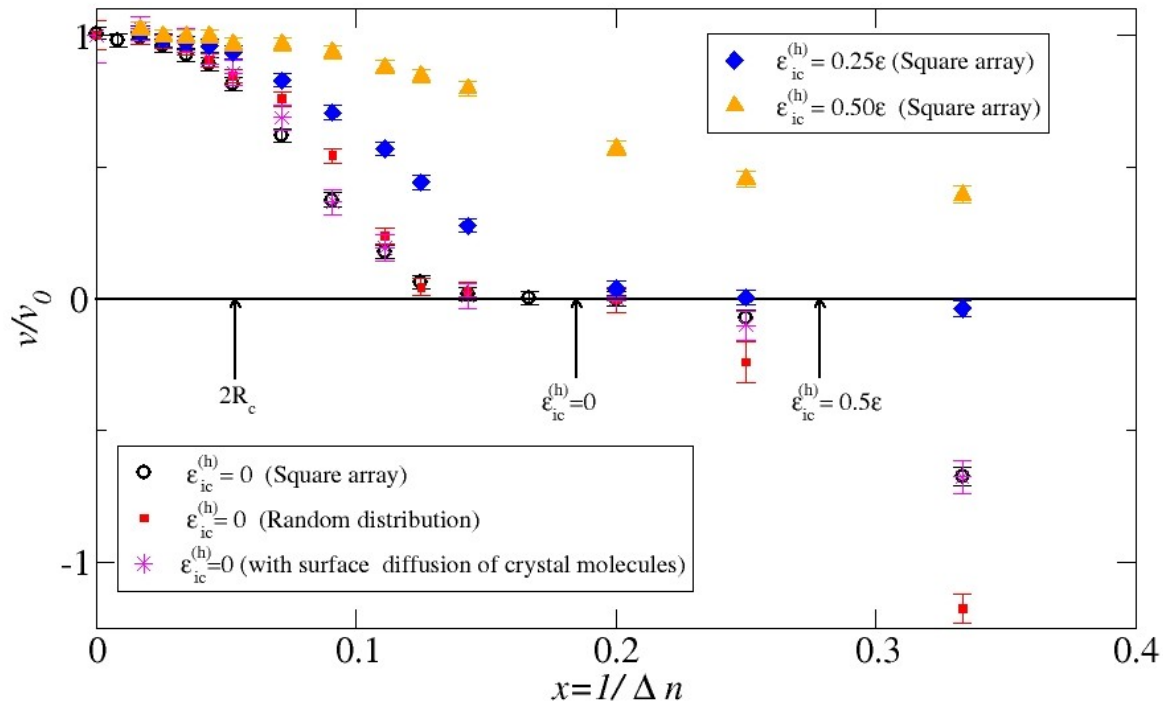
- Step growth is always favored when the free energy of the system (solution plus crystal) is lowered by adding a layer to the crystal. Conversely, it will not occur if adding a layer raises the free energy.

$$F(N+1 \text{ layers}; \Delta n) > F(N \text{ layers}; \Delta n) \quad \longrightarrow \quad \text{pinning}$$

$$\Delta n < L \times \left(\sqrt{1 + 4 \gamma / (L \Delta \mu)} - 1 \right) \xrightarrow{L \rightarrow \infty} 2 \gamma / \Delta \mu = 2 R_c$$

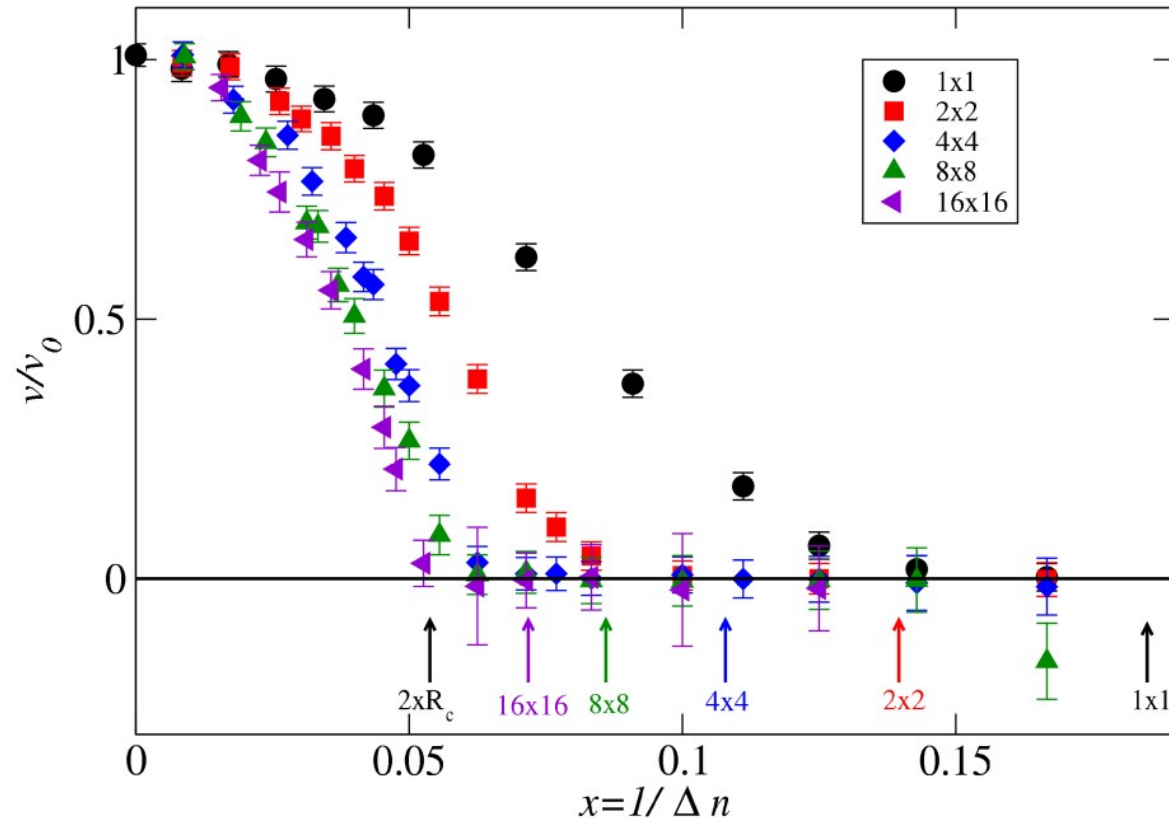
- In between these thresholds, “pinning” is a question of time scales.

Test of CV: small impurities



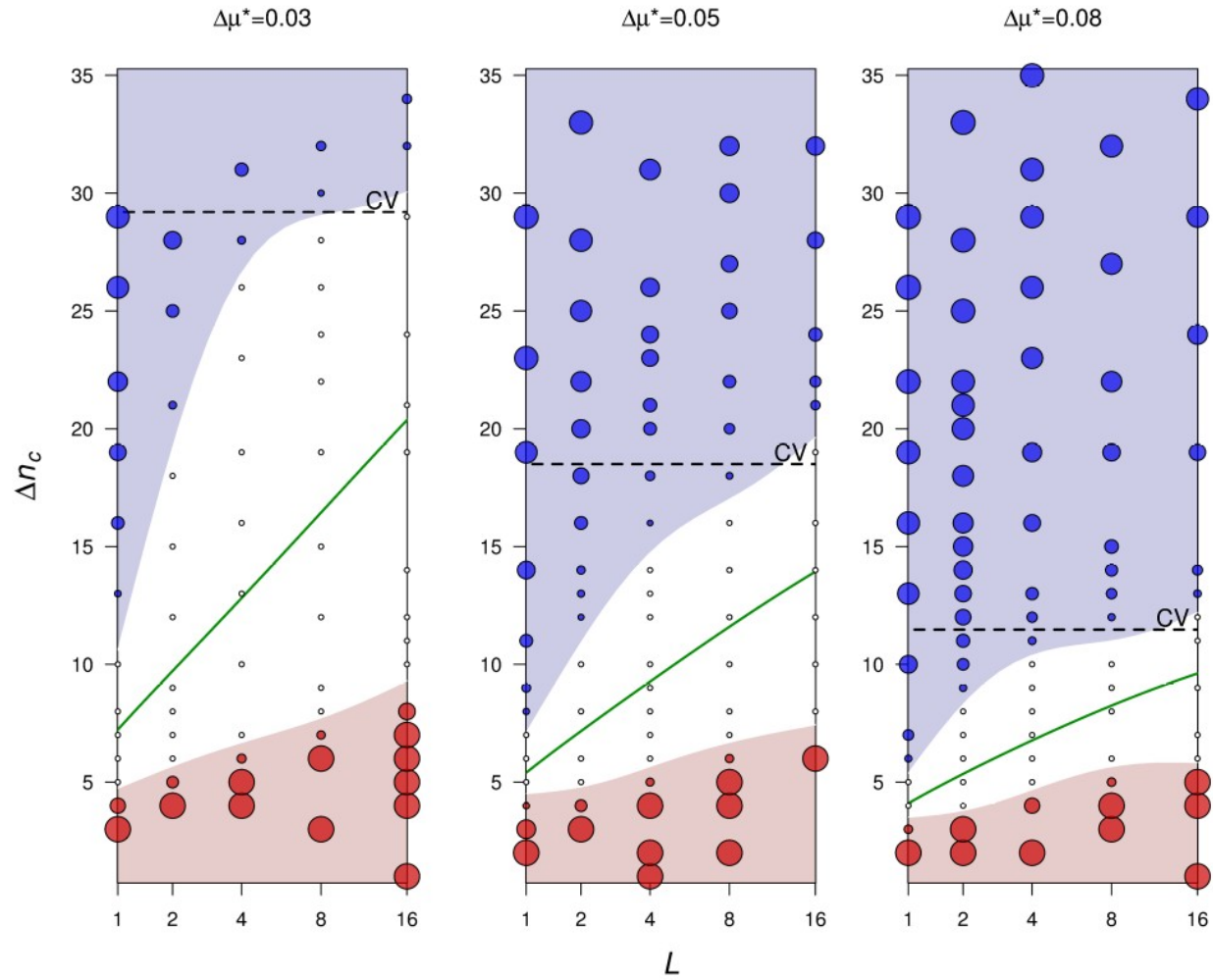
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Test of CV: larger impurities

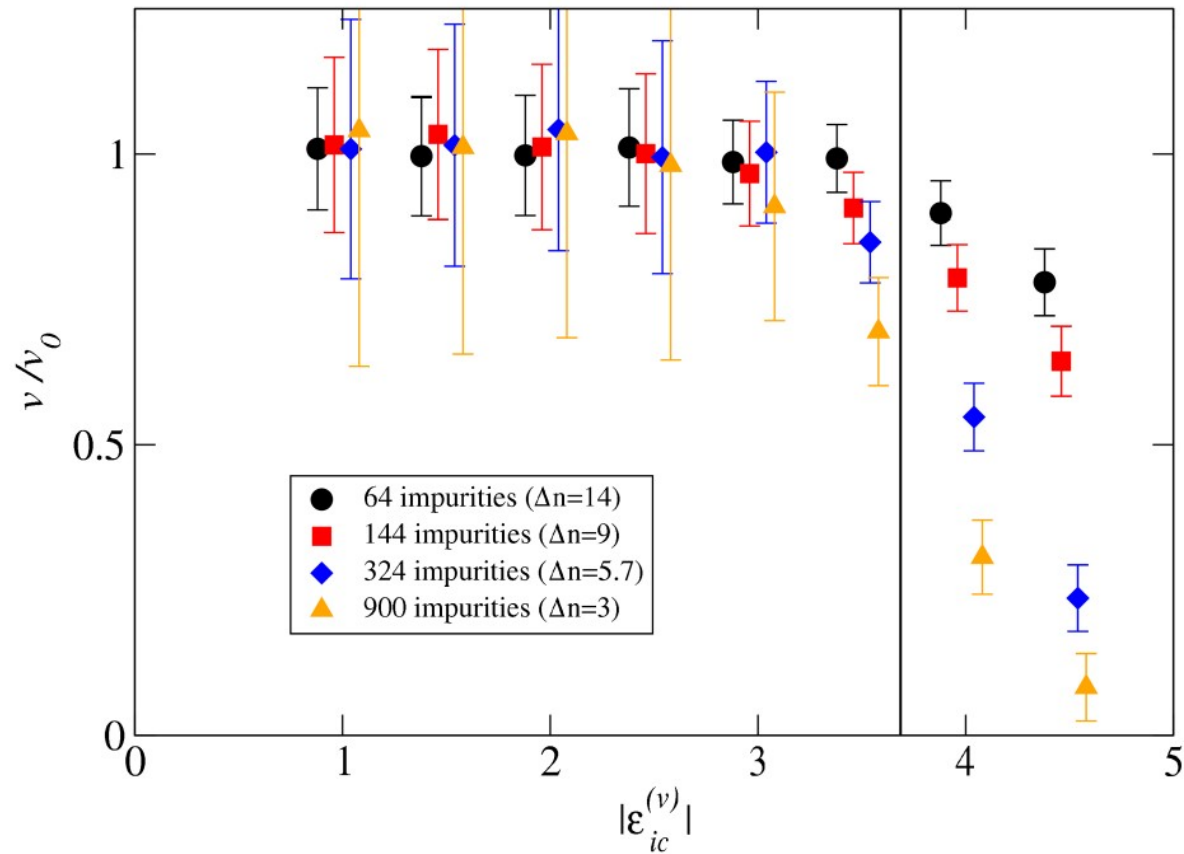


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Putting it all together



Dynamic impurities



- Long residency times required for impurities to block step growth